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*Technology and Culture* (ISSN 0040-165X) is published quarterly, January, April, July, and October, by The University of Chicago Press. Subscriptions: institutions, \$71.00; individuals, \$32.00. Student rate: 1 year \$20.00 (photocopy of valid student I.D. must accompany subscription). Emeritus: 1 year \$26.00. In Canada: add 7%. Add \$6.00/year postage for subscriptions mailed outside the U.S.A. and its possessions. Subscription agent for Japan: Kinokuniya Company, Ltd. Individuals have the option to order directly from The University of Chicago Press. Single copies: institutions \$17.75; individuals \$8.00. Back issues are available from 1989 (vol. 30). Subscriptions include membership in the Society for the History of Technology. Checks should be made payable to The University of Chicago Press, P.O. Box 37005, Chicago, Illinois 60637. For subscription information, write; FAX: (312) 753-0811; or E-mail, subscriptions@journals.uchicago.edu.

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Editorial correspondence, manuscripts, and books for review should be sent to Dr. John M. Staudenmaier, Henry Ford Museum, P.O. Box 1970, Dearborn, Michigan 48121. Further instructions on submissions follow the table of contents.

Published by The University of Chicago Press, Chicago, Illinois 60637; The University of Chicago Press Ltd., London W.C. 1. Second-class postage paid at Chicago.

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The paper used in this publication meets the minimum requirements of American National Standard for Information Sciences—Permanence of Paper for Printed Library Materials, ANSI Z39.48–1984. (∞)

POSTMASTER: Send address changes to *Technology and Culture*, The University of Chicago Press, P.O. Box 37005, Chicago, Illinois 60637.